

Notice of References Cited	Application/Control No. 10/693,189	Applicant(s)/Patent Under Reexamination INOUE, TAKASHI	
	Examiner Gevell Selby	Art Unit 2622	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,181,380	01-2001	Toyofuku et al.	348/373
*	B	US-5,867,744	02-1999	Matsukawa et al.	396/287
*	C	US-5,821,994	10-1998	Tani, Nobuhiro	348/222.1
*	D	US-2005/0185002	08-2005	Kitsugi et al.	345/629
*	E	US-6,215,964	04-2001	Omiya, Akio	396/535
*	F	US-2002/0140846	10-2002	Cheung, Ping-Yim	348/372
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.